


APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention	CHEMICAL MECHANICAL POLISHING PROCESS		
Application Type : regular, utility Attorney Docket Number : NAUP0633USA			
Correspondence address: Customer Number: 027765			
			
Inventors Information: <u>Inventor 1:</u> Applicant Authority Type: Inventor Citizenship: TW Given Name: Chia-Lin Family Name: Hsu Residence: City of Residence: Tai-Nan City Country of Residence: TW Address-1 of Mailing Address: 16F-1, No. 389, Sec. 3, Chunghua E. Rd., East Address-2 of Mailing Address: District City of Mailing Address: Tai-Nan City State of Mailing Address: Postal Code of Mailing Address: Country of Mailing Address: TW Phone: Fax: E-mail: <u>Inventor 2:</u> Applicant Authority Type: Inventor Citizenship: TW Given Name: Teng-Chun Family Name: Tsai Residence: City of Residence: Hsin-Chu City			

Country of Residence: TW
Address-1 of Mailing Address: 2F, No. 11, Lane 102, Chin Chu Rd.
Address-2 of Mailing Address:
City of Mailing Address: Hsin-Chu City
State of Mailing Address:
Postal Code of Mailing Address:
Country of Mailing Address: TW
Phone:
Fax:
E-mail:

Attorney Information:

practitioner(s) at Customer Number:

027765



as our attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.